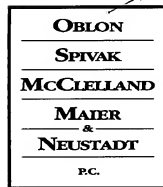




Docket No.: 245637USO

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313



ATTORNEYS AT LAW

RE: Application Serial No.: 10/716,427
Applicants: Takashi TATSUMI, et al.
Filing Date: November 20, 2003
For: MESOPOROUS SILICA AND PROCESS FOR
PRODUCING THE SAME
Group Art Unit: 1621
Examiner: NAGUBANDI, L.

SIR:


Attached hereto for filing are the following papers:

Request for Extension of Time (One Month)
Request for Reconsideration
Copy of Gao, et al.

Our credit card payment form in the amount of \$120.00 is attached covering any required fees. In the event any variance exists between the amount enclosed and the Patent Office charges for filing the above-noted documents, including any fees required under 37 C.F.R. 1.136 for any necessary Extension of Time to make the filing of the attached documents timely, please charge or credit the difference to our Deposit Account No. 15-0030. Further, if these papers are not considered timely filed, then a petition is hereby made under 37 C.F.R. 1.136 for the necessary extension of time. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND,
MAIER & NEUSTADT, P.C.


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